

501.30414V22

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KATO, et al.

Serial No.: 09/766,596

Filed:

January 23, 2001

For:

VACUUM PROCESSING APPARATUS AND OPERATING

METHOD THEREFOR

FURTHER SUPPLEMENTAL PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

January 14, 2002

Sir:

Prior to examination of the above-identified application, and supplementing the Preliminary Amendment filed January 23, 2001, and Supplemental Preliminary Amendment filed May 29, 2001, please further amend the above-identified application as follows:

IN THE CLAIMS

Please rewrite the claims presently in the application as follows:

27. (Amended) A conveyor system for processing substrates in plural vacuum processing chambers, the conveyor system including:

a loader;